

 kim-office@nanolett.acs.org via manuscriptcentr

9/29/13 ☆



to me ▾

29-Sep-2013

RE: Nano Letters Manuscript Review

Manuscript ID: nl-2013-03465v

Manuscript Title: The Unusual Mechanism of Partial Fermi Level Pinning at Metal-MoS₂ Interfaces

Author(s): Gong, Cheng; Colombo, Luigi; Wallace, Robert; Cho, Kyeongjae

Dear Dr. Popov:

The manuscript mentioned above has been submitted for publication in Nano Letters. The abstract is available at the end of this message. We would greatly appreciate it if you could comment on the suitability of the manuscript for publication, and if you could submit your comments within approximately seven days of agreeing to review. If you can review but need more than seven days to do it, please let us know. We will also send the reminders to you when the review deadline passes. In the case that you cannot do so, we would also welcome review from any of your students and postdocs whom you feel suitable. If you would be so kind to let us know the name of the reviewing student, we will add their name to the reviewer data bank.

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We would like to request that you pay careful attention to the citations in the paper. Do the authors provide proper attribution both within the immediate subject field as well as the related areas of research? Failure to cite properly related work reduces the impact of reports and can be grounds for rejection if directly relevant work is ignored.

If you are unable to review this manuscript, please let me know by replying to this email message. Your suggestions of several alternative reviewers along with their email addresses, if available, would be most helpful.

Sincerely,

Prof. Philip Kim
Associate Editor
Nano Letters

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